IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.:

09/675,627

Confirmation No.:

9578

First Named

Inventor:

Michael Rumer

Filing Date:

September 29, 2000

Group Art Unit:

2822

Examiner:

Pamela E. Perkins

Atty. Docket No.:

M-8570 US

Title:

PVD Deposition Process For Enhanced Properties Of Metal Films

Assignee:

Novellus Systems, Inc.

San Francisco, California November 26, 2002

Box Non-Fee Amendment COMMISSIONER FOR PATENTS Washington, D. C. 20231

AMENDMENT

Sir:

This is in response to a non-final office action mailed on August 28, 2002, which set a shortened statutory period for response that expires on November 28, 2002. In view of the following amendment and remarks, reconsideration is respectfully requested.

In the Specification:

Please delete the paragraph at page 5, lines 6-14, and replace it with the replacement paragraph set forth below. A copy of the replacement paragraph in marked form appears in Appendix 1.



LAW OFFICES OF KJERVEN MORRILL LLP San Jose, CA San Francisco, CA PVD is typically performed in a cluster tool, which includes at least a separate module for each layer to be deposited. For example, to produce a Ti/TiN/Al/TiN interconnect stack, titanium is deposited in a first module, titanium nitride in a second, aluminum in a third, and the titanium nitride overlayer in a fourth module. Commercially available PVD cluster tools include the Inova®, provided by Novellus Systems, Inc. (San Jose, CA) and the Endura®, provided by Applied Materials (Santa Clara, CA). Standard PVD processes and equipment are described, for example, in Chapter 10 of

11.290

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Sir:

Transmitted herewith are the following documents in the above-identified application:

(1) Return Receipt Postcard;

(2) This Transmittal Letter (in duplicate);

(3) Amendment including Appendices 1, 2 &3 (19 pgs.);

(4) Submission of Formal Drawings (1 pg.); and (5) Formal Drawings (3 sheets).

The fee has been calculated as shown below:

CLAIMS AS AMENDED

Highest No. Present Previously Claims Remaining Rate Paid For Extra [] After Amendment Total . 0.00 x \$18.00 \$ 0 22 Minus 22 Claims Independent 0.00 \$ x \$84.00 0 Minus 4 Claims \$ for the first filing of one or more multiple dependent claims \$ Fee for Request for Extension of Time (month(s)) \$ Fee for \$ Total additional fee for this Amendment: 0.00 \$ Please charge our Deposit Account No. 19-2386 in the amount of

Conditional Petition for Extension of Time: If an extension of time is required, the Ø Commissioner is authorized to deduct the necessary fee from Deposit Account No. 19-

Also, charge any additional fees required and credit any overpayment to our Deposit \boxtimes Account No. 19-2386.

EXPRESS MAIL LABEL NO:

EV 259 161 652 US

Respectfully submitted,

K. Alison de Runtz Reg. No. 37,119